High Efficiency Photovoltaics: Meeting the Terawatt Challenge

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Photovoltaics for Energy Supply
Limits to Photovoltaic Efficiency
PV Technology Comparison: Si, Thin Films, Concentrators, Nanostructures
Multijunction PV: Path to Ultrahigh Efficiency
Nanostructures in Photovoltaics



Crystalline Silicon vs. other Solar Technology



- Now appears that c-Si can eventually reach DOE cost goals
- Thin film modules can get there first, but efficiency limits, materials issues
- Innovative and disruptive technologies must have "film-like" cost/area and >20% efficiency



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Materials: CdTe, Culn_xGa_{1-x}Se₂, poly-Si, amorphous Si





CdTe Thin Film

- •Q4 2008 \$1.08/Watt
- •56% gross margin
- •750 MW production capacity

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PV Resources: Materials



*from P.H. Stauffer et al, Rare Earth Elements - Critical Resources for High Technology, USGS (2002)

PV Materials by Production and Reserve



			Annual PV	Production	(GigaWatts/year
PV Feedstoc	k Production and	Reserve Base	0.3	1.5	50 (2020)
Feedstock	World	Reserve	PV Fee	dstock Cons	umption
Material	(1000s of ton/year)	Base* (1000s of ton/year)	(1 (2000)	1000s of ton/yea (2005)	ır) (2020)
Si (c-Si)	1 000	abundant	4 ⁽¹⁾	15 ⁽²⁾	150 ⁽³⁾
Te ⁽⁴⁾ (CdTe)	0.3(Cu)	47	0.030	0.15	5
In ⁽⁴⁾ (CIGS)	0.5 (Zn)	6	0.030	0.15	5
Ga ⁽⁵⁾ (GaAs)	184 (AI)	>1100	0.008	0.041	1.4
As ⁽⁵) (GaAs)	59	1100	0.008	0.041	1.4

Material use in module production (grams / Watt): (1) 13, (2) 10, (3) 3, (4) 0.1, (5) 0.025

*: Resources that are currently economic, marginally economic and some of those that are currently subeconomic

Sources: US Geological Survey 2004 (http://minerals.usgs.gov/minerals/pubs/mcs/), M.A. Green, Prog. Phot. 14 (2006) 743-751; G. Willeke, Fraunhofer Institut

Si and Te Data From G. Willeke, Fraunhofer ISE

Cost/Efficiency of PV Technology Argues for High Efficiency





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Single Junction Solar Cells





PV Figures of Merit



Maximum Solar Cell Efficiencies



(Henrv)

Measured Theoretical

References

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3-gap GalnP/GaAs/Ge cell @240suns (Fraunhofer)

Phys. Rev. Lett., 72, 3851 (1994).
ta, "Solar Cell Efficiency Tables
2006)
rator Photovoltaics," Proc. 20th
elona, Spain, 6-10 June 2005.
GalnP/ GalnAs/ Ge Concentrator= $1 - TS/E = 1 - (4/3)T/T_{sun}$ (Henry)
Ideal 36-gap solar cell at 1000 suns (H

5800 K

93%

56%Ideal 3-gap solar cell at 1000 suns(Henry)50%Ideal 2-gap solar cell at 1000 suns(Henry)

95% Carnot eff. = 1 – T/T_{sun} T = 300 K, T_{sun} \approx

Max. eff. of solar energy conversion

3-gap Gain /GaAs/Ge cen @2+05uns (i raunioier)	
41.1 %	44% Ultimate eff. of device with cutoff E _g : (Shockley, Queisser)
3-gap GalnP/GaAs/Ge cell @ 1 sun (Spectrolab) 32.0%	 43% 1-gap cell at 1 sun with carrier multiplication (>1 e-h pair per photon) (Werner, Kolodinski, Queisser)
1-gap solar cell (Si, 1.12 eV) @92 suns (Amonix)	37% Ideal 1-gap solar cell at 1000 suns (Henry)
27.6% 1-gap solar cell (GaAs, 1.424 eV) @1 sun (Kopin) 25.1%	31%Ideal 1-gap solar cell at 1 sun(Henry)30%Detailed balance limit of 1 gap solar cell at 1
1-gap solar cell (silicon, 1.12 eV) @1 sun (UNSW)	sun (Shockley, Queisser)
3/15/09 25.0 %	Richard King



Detailed Balance Limit for Solar Cell Efficiency



Open Circuit Voltage Offset from Bandgap: Photon Entropy $\Delta F = \Delta H - T \Delta S$

 $qV_{oc} = E_g - T k ln \Omega = E_q - kT ln 46,200 = E_q - 10.7 kT$



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Single-junction Cells vs. Multijunctions



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Concentrator Photovoltaics: An Approach to Reap Benefit from Expensive Ultrahigh Efficiency Cells



UMUWA SOLAR POWER STATION



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Module and BOS cost assumptions from: [1] Swanson, Prog. Photovolt. Res. Appl. 8, 93-111 (2000).



Detailed Balance Models

Assumptions:

P. Wurfel, Journal of Physics C: Solid State Physics 15, 3967-3985 (1982)

- Perfect absorption of incident photons
- Photo-current loss through radiative reemission:

Detailed Balance of First Subcell



$$\frac{J_1}{q} = {}^{AM1.5}N - {}^{rad}N_1$$



$$\frac{J_n}{q} = {}^{AM1.5}N + {}^{rad}N_{n-1} - {}^{rad}N_n$$

Detailed Balance:E1 (GalnP)Ge-based Triple-junctionE2 (GaAs)Isoefficiency PlotGe







Detailed Balance: GalnP/GaAs-Based Four-Junction Isoefficiency Plot





- Narrow-gap bottom subcell eases current-matching requirements for E₃
- Iso-efficiency contours → atmospheric absorption



Detailed Balance: Summary

Configuration	Optimal Subcell Bandgaps (eV)	Maximum Efficiency
Ge-Based Triple-Junction (Series connected)	1.90, 1.42, 0.67	46.3%
Si-Based Triple-Junction (Series connected)	2.00, 1.49, 1.12	51.2%
Optimal Four-Junction (Series connected)	2.00, 1.49, 1.12, 0.72	57.9%
GalnP/GaAs-Based Four-Junction (Series connected)	1.90, 1.42, 1.02, 0.60	54.9%



Efficiency vs. Bandgap Variation in 4 Junction Cell



Variation of efficiency of optimal 100 sun AM1.5 series-connected four-junction solar cell with changes of each subcell bandgap. Each subcell is varied independently, maintaining the other subcells at their optimum bandgap of 2.00, 1.49, 1.12, and 0.72 eV respectively.



Improvements in Solar Cell Efficiencies



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US DOE











Lattice Matched and Metamorphic 3-Junction Cell Cross-Sections



Lattice-Matched (LM)



Lattice-Mismatched or Metamorphic (MM) *Richard King*

EQE and PL of Subcells Matched to 1%-In and 8%-In GalnAs





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High Efficiency GalnP/GalnAs/Ge Triple Junction



• AM1.5 Direct, Low-AOD standard spectrum

0.269 cm²
 aperture area

39.0% record
efficiency,
236 suns, 25°C



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Metamorphic InGaAs Buffer Layers

Step Graded Buffer

Linearly Graded Buffer



P. Kidd et al. Journal of Crystal Growth (1996)



Metamorphic 3J Solar Cells



M.W. Wanlass et al, Proceedings of the 4th WCPEC (2006)

Record Efficiency 3J Solar Cells







	Lattice Matched	Lattice Mismatched
V _{OC}	3.054 V	2.911 V
J _{SC}	0.1492 A/W	0.1596 A/W
FF	0.881	0.875
Concentration	454 suns	326 suns
Efficiency	41.1%	40.8%
	Fraunhofer	NREL

40.1%	40.7%
Spectrolab	Spectrolab

R.R. King et al. APL 90 183516 (2006)



















Subcell Integration by Bonding





High-performance solar cells:

- Multi-junction, current-matched tandem monolithic solar cell
- Optimal bandgap sequence achievable

Wafer bonding:

- Non-lattice-matched materials integration
- Misfit defect isolation at only bonded interface



4 Junction Solar Cell Device via Bonding/Layer Transfer

Series-connected GaInP/GaAs/ InGaAsP/InGaAs	Band Gap (eV)	GaInP	1.90
		GaAs	1.42
		InGaAsP	1.02
		InGaAs	0.60

Detailed Balance Efficiency = 54.9%

J.M. Zahler Ph.D. Thesis, California Institute of Technology (2005)





Wafer Bonding/Layer Transfer Process

- 1. Ion implantation:
 - Defects / Internal
 Surfaces
 - -Pressure
- 2. Bond formation:
 - Smooth, particlefree surfaces
 - -Surface activation
- 3. Thermal processing:
 - Bond strengthening
 - -Exfoliation
- 4. Result:
 - Thin, uniform transferred film



InGaP/GaAs/Ge/SiO₂/Si Two Junction Cells Fabricated by Wafer Bonding/Layer Transfer







After Ge wet etch & CMP



After InGaP/GaAs Growth and Cell Processing

AM 1.5D Light I-V



Cell Data







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InGaAs/InP/Si Low Bandgap Cell with Performance Equivalent to State-of-the-Art InGaAs/InP



	<u>ρ.2 mm</u>

Cell Description	JSC(mA/cm²) VOC(mV)		Fill Factor	
Bulk InP Reference Cell Bulk InP + RIE + wet etch	-59.7 -61.7	329 342	0.686 0.685	
(InPOI + RIE + wet etch)	-62.7	338	0.675	

Process <u>Eliminates</u> InP Substrate Cost
 •Template Fabrication Cost ~ Epi Cost



Zn₃**P**₂ - An Earth Abundant Semiconductor





•Energy Gaps – Direct and Indirect nearly aligned @ ~1.3 eV

cm 1 2 3 4



•Zinc Phosphide not commercially available – have to grow crystals



Zn_3P_2 wafer in vacuo 355nm excitation, 10 kHz Zn₃P₂ Energy Bands and 10⁰ • fl. signal 10° **Heterojunction Cell** Zn₃P₂:ZnS:ZnO Band Alignment -E 10⁻² Lifetime at direct gap: diffusion length ~10 um. AM 1.5 G Illumination 10⁻³ Zn_3P_2 ZnS ZnO:Al 10 20 30 40 0 time / ns 17Feb2009 $\Delta E_c = 0.2 \text{ eV}$ 1.7 -Indirect Gap $V_{OC} \sim 0.8 \ V$ 1.65 - Direct Gap 1.6 -Indirect Gap + 3kT Energy (eV) 1.55 $\Delta E_v = 2.3 \text{ eV}$ 1.5 1.45 1.4 1.35 1.3 200 0 100 300 400 Temperature (K)



solar cell based on arrays of Si wires features:

- Orthogonalize light absorption and photocarrier collection
- Retain efficiencies competitive with planar, crystalline Si solar cells
- Compatible with low minority carrier diffusion length
- Si wire arrays formed by SiCl₄ chemical vapor deposition
- Can be formed into flexible that are peeled off template Si



Device Modeling





1-D carrier transport modeling indicates that high efficiencies can be maintained for low diffusion length materials

Modeling indicates $\eta > 15\%$, $V_{oc} > 500 \text{ mV}$ achievable with $L_n = 1 \ \mu m$ in Si, provided junction recombination is not limiting

B. M. Kayes et al., J. Appl. Phys. 97, 114302 (2005)

- Reactive Ion Etching used to define wires, to deconvolute
 - Device geometry effects

from

- material quality issues, and
- device fabrication difficulties

With 5 μ m diameter, 50 μ m long wires we see:

device size ~0.1 cm², $V_{oc} = 505 mV$, $J_{sc} \approx 20 mA/cm^2$, FF = 58 %, $\eta \approx 5.7$ %

(diffused B emitter, 5 Ω cm n-Si(100) base) High V_{oc} achievable in Si wire array cells

B. M. Kayes et al., Proc. of 33rd IEEE PVSC (2008)



0.00

-0.02



0.0

-0.2

0.2

0.6



Prototype Si Wire Array Devices



Vapor-Liquid-Solid (VLS) Growth



- Single crystal wires
- Growth direction controlled by substrate orientation
- High growth rates (up to $\sim \mu m/s)$
- Inexpensive gas phase precursors
- Atmospheric pressure growth possible
- Wide range of diameters possible

R. S. Wagner and W. C. Ellis, App. Phys. Lett. 4, 89 (1964)







Si Wire Array Cell Milestones





Growth of vertically-aligned, patterned Si wire arrays over large (>1 cm²) areas, using Au, Cu, and Ni catalyst metals.

Kayes, B. M.; Filler, M. A.; Putnam, M. C.; Kelzenberg, M. D.; Lewis, N. S.; Atwater, H. A. *Applied Physics Letters* **2007**, 91, (10), 103110-3.



Demonstration of Si wire array photoelectrochemical cell

Maiolo, J. R. I.; Kayes, B. M.; Filler, M. A.; Putnam, M. C.; Kelzenberg, M. D.; Atwater, H. A.; Lewis, N. S. *Journal of the American Chemical Society* 2007, 129, (41), 12346-12347.
Goodey, A. P.; et. al. *J. Am. Chem. Soc.* 2007, 129, 12344-12345.

Si Wire Array Cell Milestones







Recycling of patterned growth substrate and repeated re-growth of wire arrays

Spurgeon, J. M.; Plass, K. E.; Kayes, B. M.; Brunschwig, B. S.; Atwater, H. A.; Lewis, N. S. *Applied Physics Letters* **2008**, 93, (3), 032112-3.



Ni-catalyzed NW



 $L_{p,eff} \sim 10 \ \mu m$

"Fundamentals of Solar Cells", pp. 83

LIST CHINOR

Absorption concentration: Si wires act as waveguide array



Percent solar absorption vs. area fraction

Baffle

Sample



Sample beam position

Referen

peam position

Two Plasmonic PV concepts Backside SPP



Nanoparticle Scatterer/ Dielectric Waveguide





H. R. Stuart and D. G. Hall, APL 69, 2327, 1996 S. Pillai et al, APL 88, 161102, 2006





Particle scattering and absorption effects on spectral response







K.Nakayama, K.Tanabe, and HAA Appl. Phys. Lett. 93, 121904 (2008)



Surface Plasmon Incoupling at Sub- λ (100 nm)Grooves









Angular Dependence of Absorption Enhancement



V.E. Ferry, et.al. Nano Letters, 8, 4391-4397 (2008)



SPP-Induced Quantum Dot Excitonic Absorption





Detailed balance between absorption and emission cones

Results:

light in medium will be randomized in direction

In medium, $2n^2(x)$ times greater intensity than incident light (for Si, ~50x)

Summary

- •Photovoltaics Resource is TW-capable
- •Close to Limiting PV Efficiency for Single Junction Cells
- •Silicon PV being overtaken by thin films as leading technology
- •Multijunction PV a viable path to >50%
- •Wire Array PV scaleable large area technology

For Terawatt PV:

- •Reduce Material Thickness plasmonics
- •Earth-Abundant Materials!

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